

Micro-Pattern Gas Detectors (RD51) Workshop

Wednesday, 16 April 2008

New Technology III (14:00 - 15:50)

-Conveners: Paul Colas

time	[id] title	presenter
14:00	[20] Radiation detectors made by post-processing standard CMOS: a technologist's perspective	SCHMITZ, Jurriaan
14:30	[21] InGrid: the integration of a grid onto a pixel anode by means of Wafer Post Processing technology	BLANCO CARBALLO, Victor
14:50	[22] Track properties recorded by a GEM TimePix	Prof. BAMBERGER, Andreas
15:10	[23] First results from a prototype TPC with GEM and TimePix at Bonn	KAMINSKI, Jochen
15:30	[24] PIM: a multi-stage device using micromeshes for tracking particles	BEUCHER, Jerome